

JCK MEMS/NEMS 2023

The 14th Japan-China-Korea Joint Conference on MEMS/NEMS
17-20 September, 2023, JeJu, Republic of Korea

- MEMS/NEMS Powering The Big Data Age -

The selected papers are recommended for " Micro and Nano Systems Letters (MNSL)".

Conference Scope

- Micro/Nano Electro-Mechanical Systems (M-/NEMS)
- Micro/Nano-Fabrication Processes
- Micro/Nano-Actuators & Robotics
- Micro/Nano- Chemical & Physical Sensors
- Micro/Nano-Bio Devices & Systems
- Micro/Nano-Electronics
- Micro/Nano-Mechanics
- Micro/Nano-3D Printing Processes
- Micro/Nano-enabled Flexible & Printed Electronics
- Micro/Nano-enabled Wearable Devices
- Micro/Nano-Functional Materials & Characterization
- Networked Microsystems & IoT Technologies
- Modeling & Simulation of Manufacturing Processes
- Others



Important Dates

- Submission Deadline : 18th Aug., 2023
- Notification of Paper Acceptance : 31st Aug., 2023
- Registration Deadline : 31st Aug., 2023
- Registration Fee: USD 300 / KRW 350,000

Honorary Chair

- Eung-Sug LEE (KIMM, Korea)

Conference General Chair

- Jeongdai JO (KIMM, Korea)

Conference Co-Chairs

- Norihisa MIKI (Keio University, Japan)
- Libo ZHAO (Xi'An Jiaotong University, China)

- Organized by Korea Institute of Machinery & Materials (KIMM)
- Co-organized by Intl. Joint Laboratory for Micro/Nano Manufacturing and Measurement Technology
School of Instrument Science and Technology Xi'an Jiao Tong University
- Supported by The Society of Micro and Nano Systems(MNS)

Visit the website For all the latest Information !

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